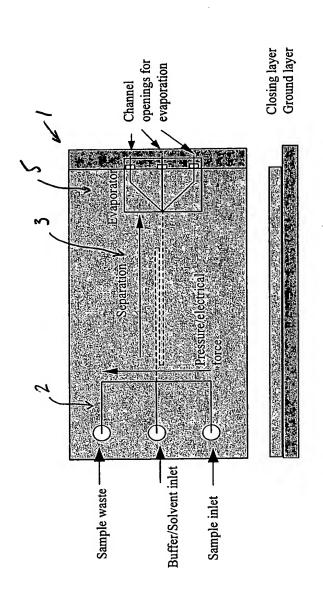


Fig.1 The increase in circumference is dependent on the relation between width vs. depth of a channel (s = width/depth). The cross section is constant. For example: A channel, which is 10 times wider than deep has an increase of more than 50% capillary force in comparison to a square one.



tr.

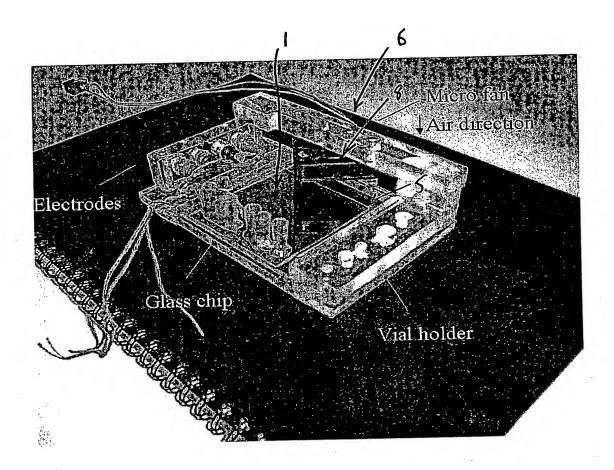
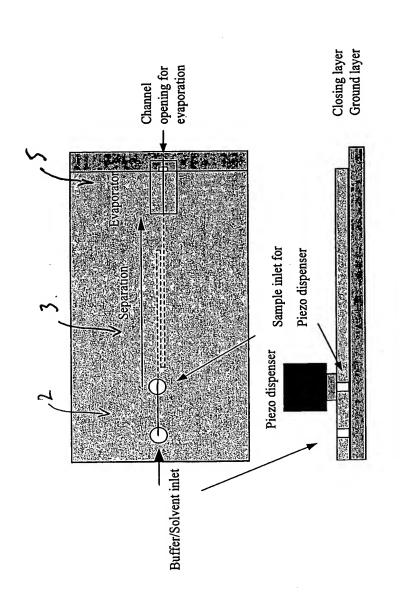


Fig. 3 Chip holder for 3in x 3in glass chips compatible with standard microscope stages; includes a micro fan for constant "fresh" air, vial holders and electrodes for sample injection

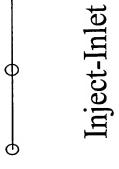


1. 5nd

Inlets

T-Inlet, modified

T-Inlet classic



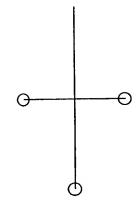
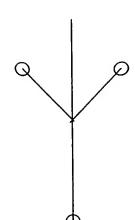


fig 5(a)



T-Inlet, anti-stream

## Separation Channel

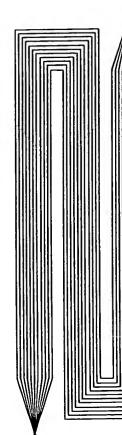
Single channel straight

Single channel meander

fig. 6(6)

fig. 6(c)

Single channel meander extra long



Channel bundle parallel, meander

fif. 6(a)

Evaporators

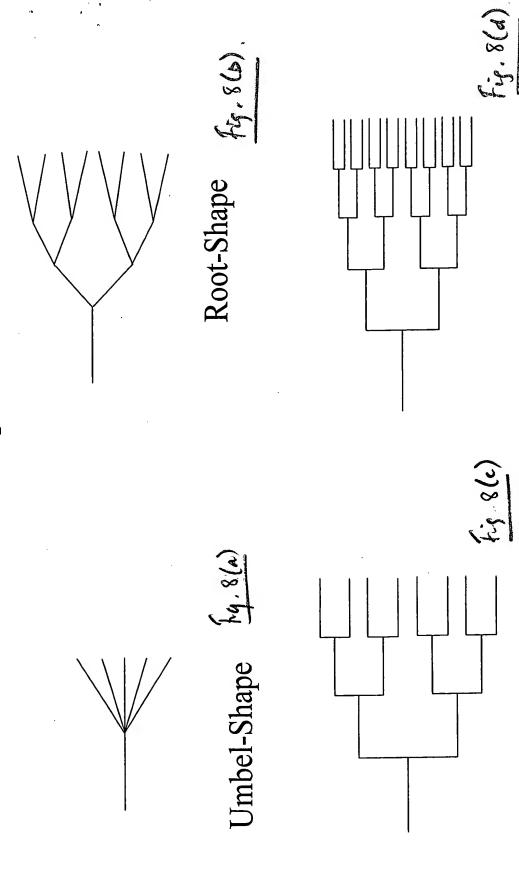
Funnel-shape

Single channel

4,7 (4)

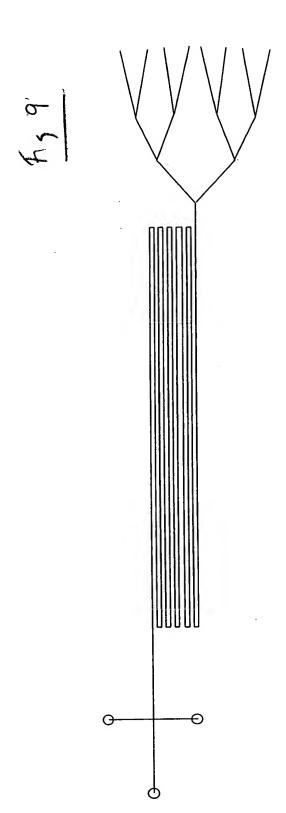
fig. 7(a)

## Multi Channel Evaporators

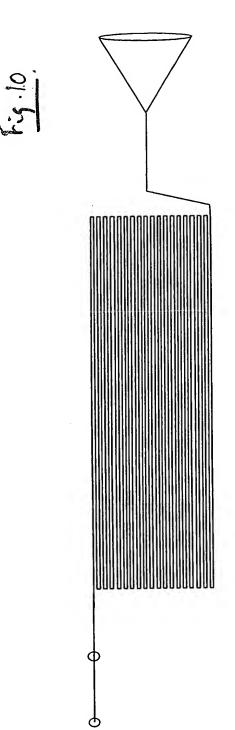


1:1 Splitter, rectangular 3-fold

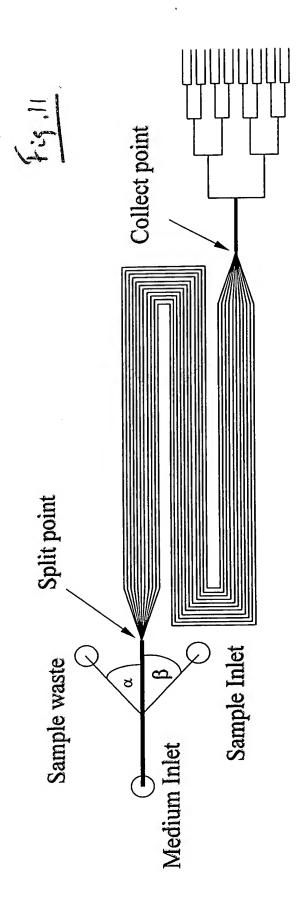
1:1 splitter, rectangular 4-fold



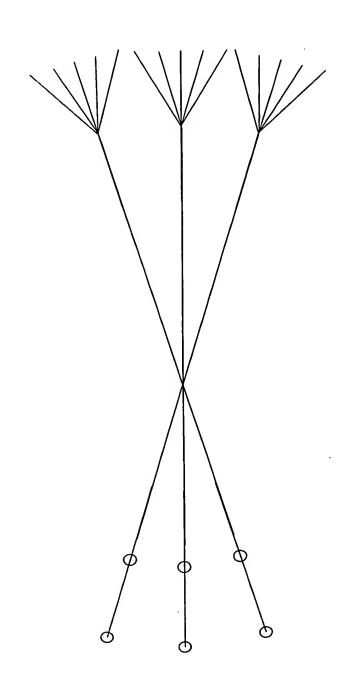
Chip design with classic T-inlet and medium length meander single channel Separator including multi channel root-shape evaporator; all channel dimensions a the same (10µm wide and 0.5µm deep)



Chip design with inject-inlet including extra long single meander channel for separation; funnel-evaporator

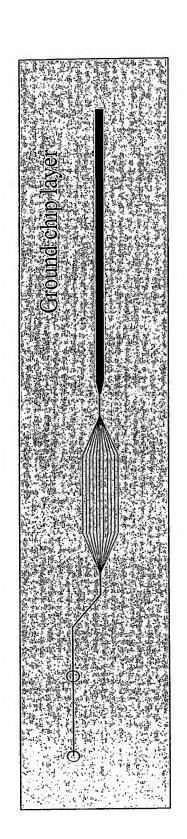


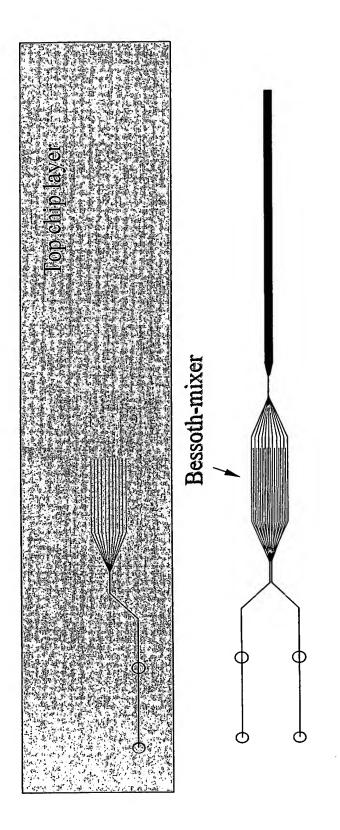
Chip design including an anti-stream inlet with different angles  $(\alpha, \beta)$  for different regions; bundle of 11 separation channels meandering parallel; sample inlet and sample waste, channel dimensions vary between the evaporator 4-fold 1:1 splitter



Chip design for a three compound synthesis including three umbel-shape evaporators and three inject-inlets

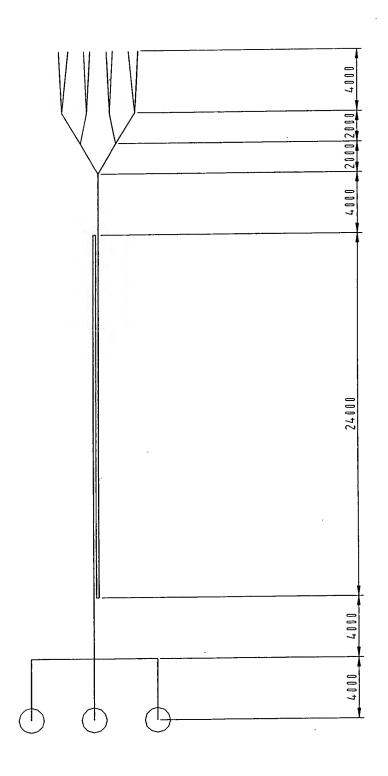
7.5.12





Chip design for Immuno-assays including two inject-inlets on two diffent layers and following "Bessoth-mixer" (Lit); single wide channel evaporator

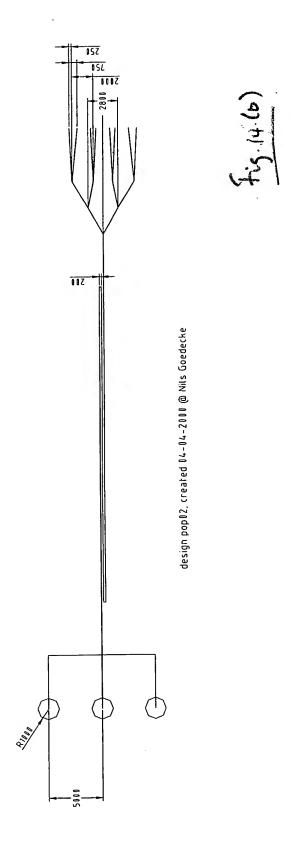
7, 13



design pop12; created 14-14-2111 @ Nils Goedecke

Channel width 110µm after etching, depth 25 µm over the whole structure

Fig. 14(a)



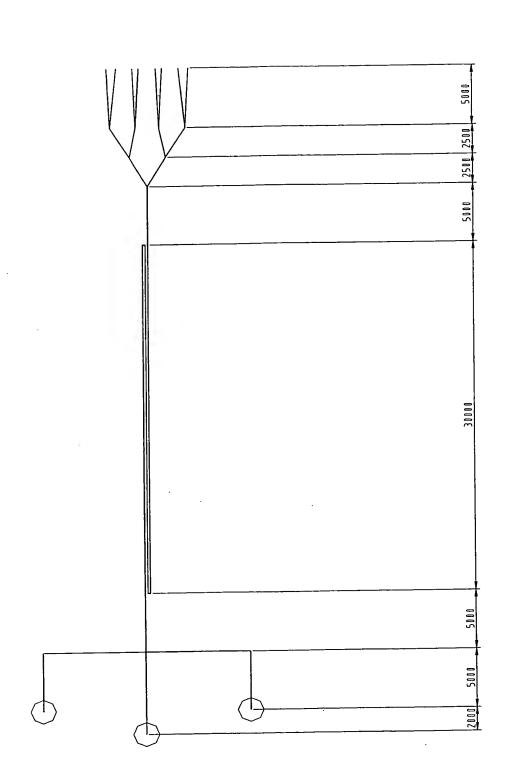
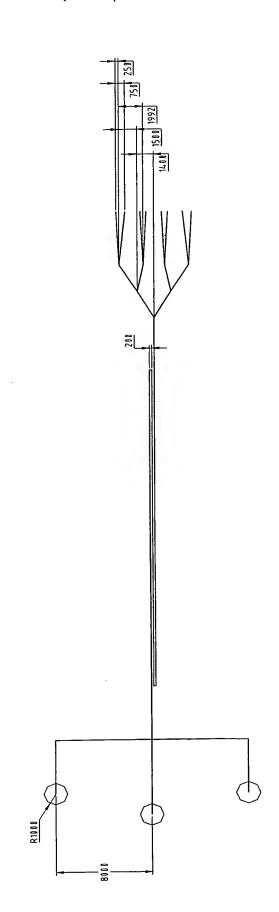


Fig 15(a)

channel width 41 microns for each design

Channel width after etching 60μm; depth 10 μm

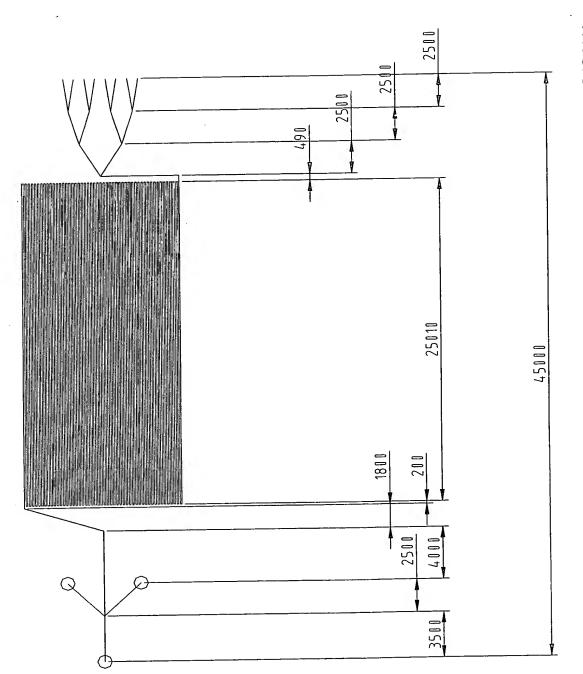
design popli3a by Nils Goedecke 23. June 2000 IC Department of Chemistry



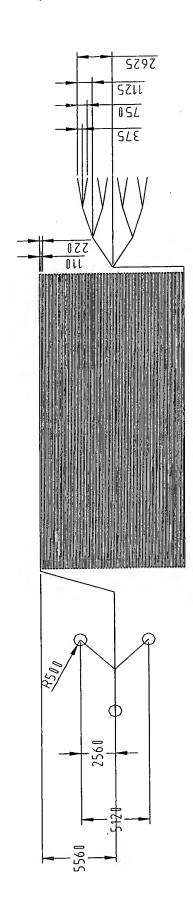
channel width 41 microns for each design

design poplija by Nits Goedecke 23. June 2000 IC Department of Chemistry

fig. 16 Ca)



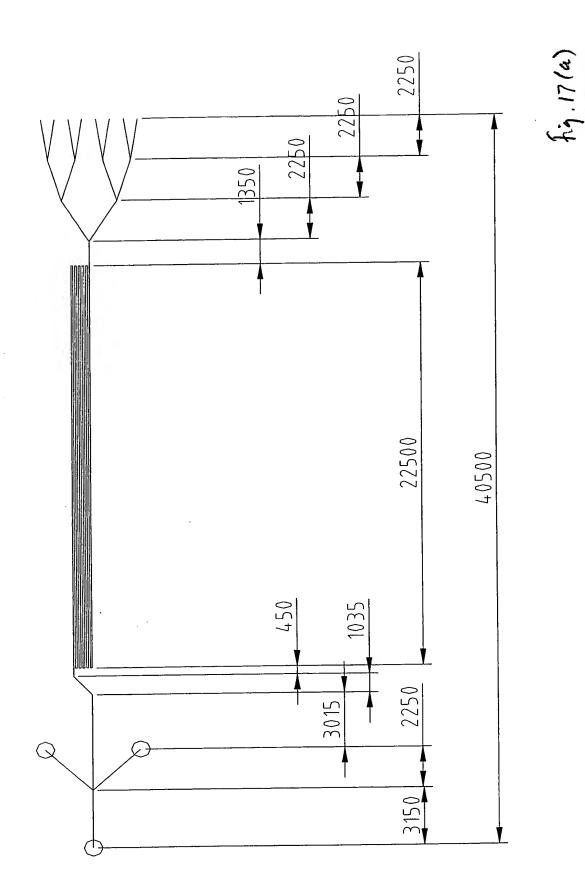
Design lim 11: S.I. 5; Sep.Ch.W. 10; EVvap.Ch.W.11 by Nils Goedecke 15.07.2011.



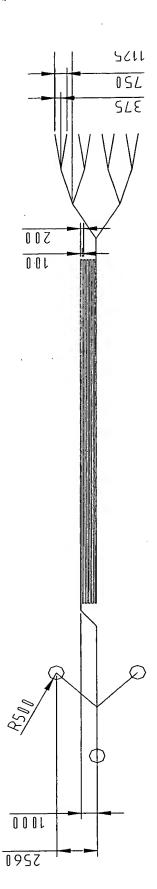
of this length  $10\mu m$  wide and  $0.1\mu m$  deep if running with a  $\eta \sim 40$  has an efficiency of more than 500000 theoretical plates in 10 min run time. This layout includes the anti-stream-inlet and a 2.5m separation channel. Theoretically, a channel

Design lim 11: S.I. 5; Sep.Ch.W. 11; EVvap.Ch.W.11 by Nits Goedecke 15.17.2000

hz. 16 (6)



Design lim 02 S.I. 5 Sep.Ch.W. 10 EVvap.Ch.W.10 by Nils Goedecke 09.11.2000

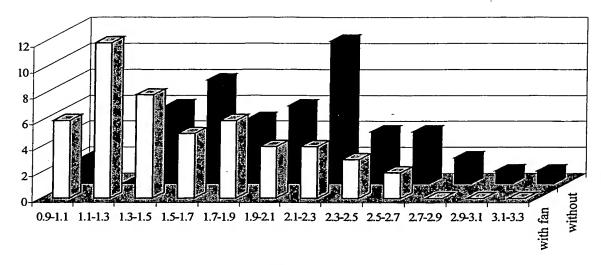


fr. 17(b)

Design lim 12 S.I. 5 Sep.Ch.W. 11 EVvap.Ch.W.11 by Nils Goedecke 19.11.2111

a). Design structure using CAD package and convert to machine format HeCd Laser λ=442nm b). Expose photoresist using DWLII system Metal Layer (Cr or Cr and Au) Photoresist-Glass Substrate c). Develop photoresist d). Etch Metal Layer e). Etch Glass f). Remove Photoresist and Metal Layer Thermally bond to coverplate - Coverplate

Fig. 18



t [s]

Velocity differences within the channel  $(60x20\mu m)$  for  $10\mu m$  latex beads in a pop02 chip driven through evaporation with and without "air condition"; measurement with 50 beads each; The average velocity with the "air condition" switched on is slightly higher than without it – visible in the left shift of the profile.

hiz.19